

DT15 Rec'd PCT/PTO 23 FEB 2005

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Henry W. White et al.  
Application Number: To be assigned  
Filing Date: Herewith  
Title: A Hybrid Beam Deposition System and Methods for  
Fabricating Metal Oxide-ZnO Films, P-Type ZnO Films,  
and ZnO-Based II-VI Compound Semiconductor Devices  
Group Art Unit: Not yet known  
Examiner: Not yet known  
Attorney Docket: MOXT-002-US

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Signature of person mailing correspondence:

  
Sunshine Limanni

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MAIL STOP PCT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**PRELIMINARY AMENDMENT**

Sir:

Please amend the above-identified application as follows, prior to the first Office Action, to place the application in condition for allowance.